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Class	Subclass
ISSUE CLASSIFICATION	

PATENT NUMBER

U.S. UTILITY Patent Application

12W	O.P.E.	PATENT DATE
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APPLICATION NO.	09/546936	CONT/PRIOR	F	CLASS	25/437	SUBCLASS	255394	ART UNIT	251762	EXAMINER	W. Lee
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Ching-Chang Hsieh
Yang-Hsin Liu
Apparatus for forming thin semiconductor process and method for feeding gas into the same apparatus

APPLICANTS

TITLE

PTO-2040
12/99

ISSUING CLASSIFICATION		ORIGINAL		SUBCLASS		CLASS		SUBCLASS (ONE SUBCLASS PER BLOCK)		INTERNATIONAL CLASSIFICATION	
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<input type="checkbox"/> TERMINAL		DRAWINGS		CLAIMS ALLOWED		
DISCLAIMER		Sheets Dwg.	Figs. Dwg.	Print Fig.	Total Claims	Print Claim for O.G.
The term of this patent subsequent to (date)		(Assistant Examiner)		(Date)		NOTICE OF ALLOWANCE MAILED
The term of this patent shall not extend beyond the expiration date of U.S. Patent No.		(Primary Examiner)		(Date)		ISSUE FEE
The terminal months of this patent have been disclaimed.		(Legal Instruments Examiner)		(Date)		Amount Due
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